



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date April 23, 2007

In re the Application of

Masaaki KURIHARA et al.

Group Art Unit: 1756

Application No.: 10/614,345

Examiner: J. RUGGLES

Filed: July 8, 2003

Docket No.: 123770

For: PHASE MASK FOR FORMING DIFFRACTION GRATING, METHOD OF FABRICATING  
PHASE MASK AND METHOD OF FORMING DIFFRACTION GRATING

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

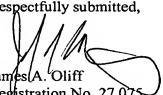
Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired February 28, 2007, an extension of time for a period of TWO months is hereby requested. Attached hereto is our Check No. 191943 in the amount of \$450 in payment for:

_____	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
<u>  X  </u>	Extension fee for response within second month pursuant to §1.136(a) (\$450.00)
_____	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

  
James A. Oliff  
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04/24/2007 DEK:MANU2 00000201 10614345

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JAO:JSA/ax1

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DEPOSIT ACCOUNT USE  
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Please grant any extension  
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